



**RESPONSE TO FINAL OFFICE ACTION  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP 1793**

**PATENT**

Attorney Docket No. M03B318

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: SEELEY et al.  
Serial No.: 10/729,454  
Filed: December 5, 2003  
Entitled: Treatment of Exhaust Gases  
Atty. Dkt. No.: M03B318

Group Art Unit: 1793  
Examiner: Paul A. Wartalowicz  
Confirmation No.: 1037

MAIL STOP AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence and every writing referred to herein as being enclosed is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 19, 2008.  
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Betty Lee

Signature of person mailing

Sir:

**RESPONSE TO FINAL OFFICE ACTION**

In reply to the Final Office Action dated March 4, 2008, the period for response having been extended to September 4, 2008, by a request for extension of three months and fee payment filed concurrently herewith, Applicants respectfully request that this application be reconsidered in light of the following remarks.

**ATTACHMENT:** Wolf et al., Silicon Processing for the VLSI Era, Volume 1: Process Technology, 191-193 (2nd Ed. 2000)